CLAIMS

We claim:

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1. A apparatus comprising:

a substrate having a source region, á drain region, and a channel region having a

- 3 void to provide a barrier to lines of force to reduce leakage current.
- 1 2. The appearatus of claim 1 wherein said void is located substantially in a center of
- 2 said channel region.

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3. The apparatus of claim 1 wherein said void is approximately 50 nm across.

- 4. The apparatus of claim 3 wherein said void is located at a depth of approximately
- 2 1000 angstroms in said channel region.
 - 5. The apparatus of claim 1 further comprising a gate region.

6. The apparatus of claim 5 wherein said void is located near an edge of said channel region adjacent to said source region.

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- The apparatus of 6 further comprising a void located near an edge of the channel
- 2 region adjacent said drain region.

- a gate region; and
- a substrate having a source region, a drain region, a channel region, and a void
- below said source region to provide a barrier to lines of force to reduce leakage current.
- 1 9. The apparatus of claim 8 wherein a void is located below said drain region.
- 1 10. The apparatus of claim 9 wherein said source region and said drain region are
- 2 under compressive stress

11. The apparatus of claim 8 wherein said source region is under tensile stress.

12. The apparatus of claim 8 wherein said drain region is under compressive stress.

The apparatus of claim 8 wherein said gate region is polysilicon.

14. The apparatus of claim 8/wherein said gate region is metal.



5. An apparatus comprising

a gate region having a void to provide a barrier to lines of force to reduce leakage

current; and

a substrate having a source region, a drain region, and a channel region.

16. The apparatus of charm 15 wherein said void is located at a depth of approximately

2 1000 angstroms in said gate region.

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17. The apparatus of claim 15 herein said gate region is polysilicon.

18. The apparatus of claim 15 wherein said gate region is metal.